

Supporting Information

High-Performance Electrochromic Films with Fast Switching Times Using Transparent/Conductive Nanoparticle-Modulated Charge Transfer†

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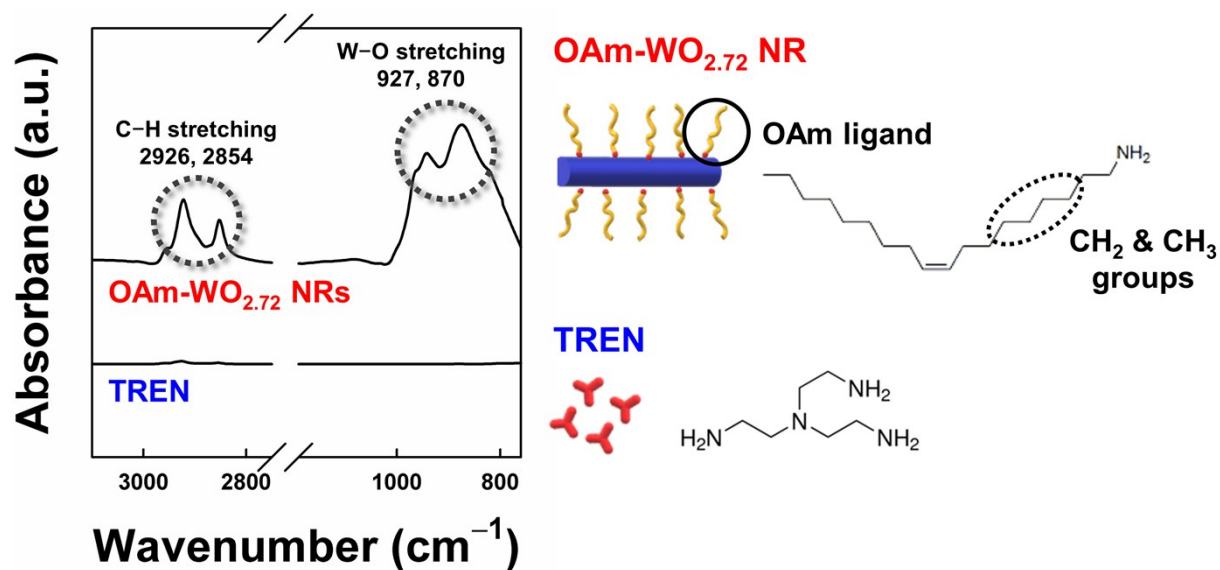


Fig. S1 FTIR spectra of pristine OAm-WO_{2.72} NRs and TREN. In the case of OAm-WO_{2.72} NRs, the C-H stretching peaks (*ca.* 2,926 and 2,854 cm⁻¹) and the W-O stretching peaks (*ca.* 927 and 870 cm⁻¹) derived from the long alkyl chains of OAm ligands and WO_{2.72} NRs, respectively, are detected. However, in the case of TREN, there are no distinct absorption peaks at those ranges.

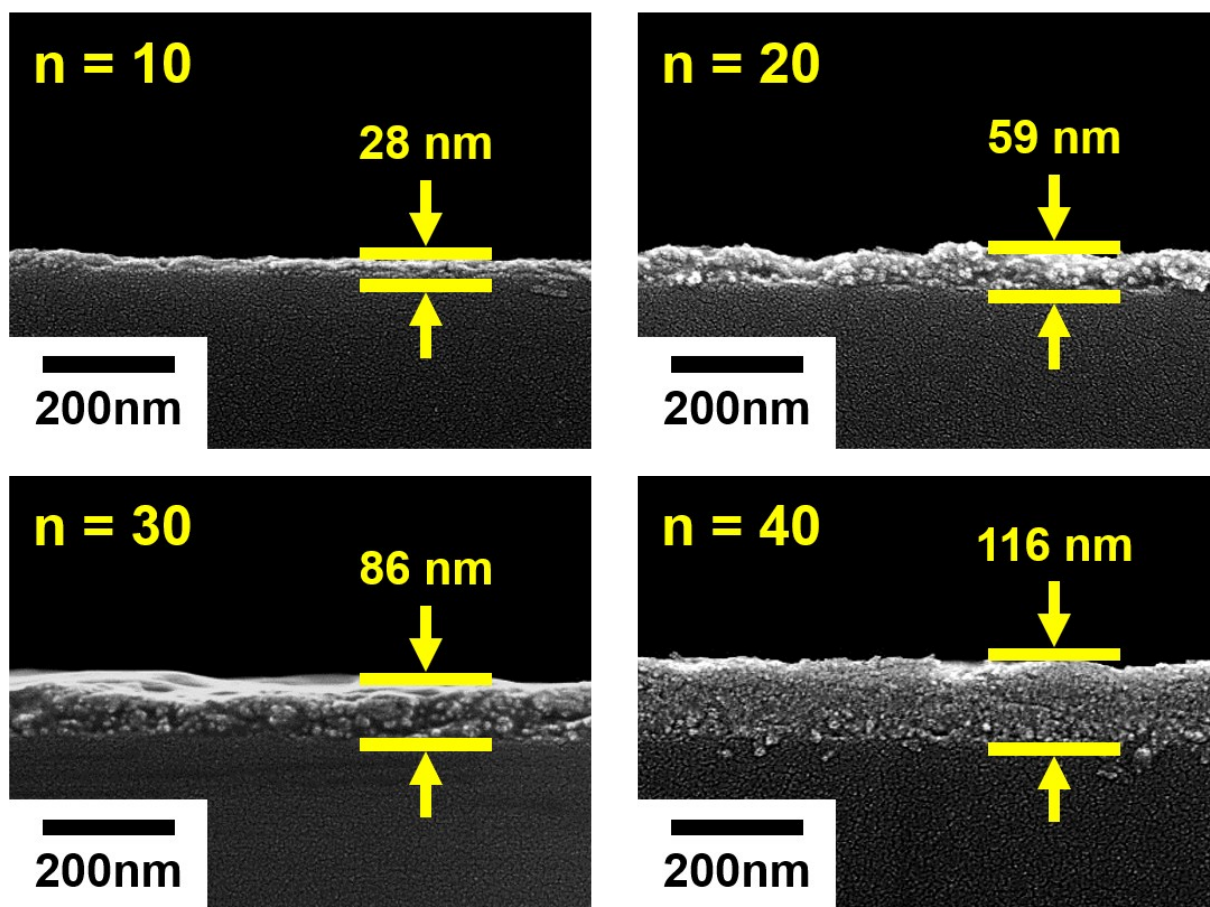


Fig. S2 Cross-sectional FE-SEM images and the corresponded thickness of $(\text{WO}_{2.72} \text{NR/TREN})_n$ multilayers as a function of bilayer number (n).

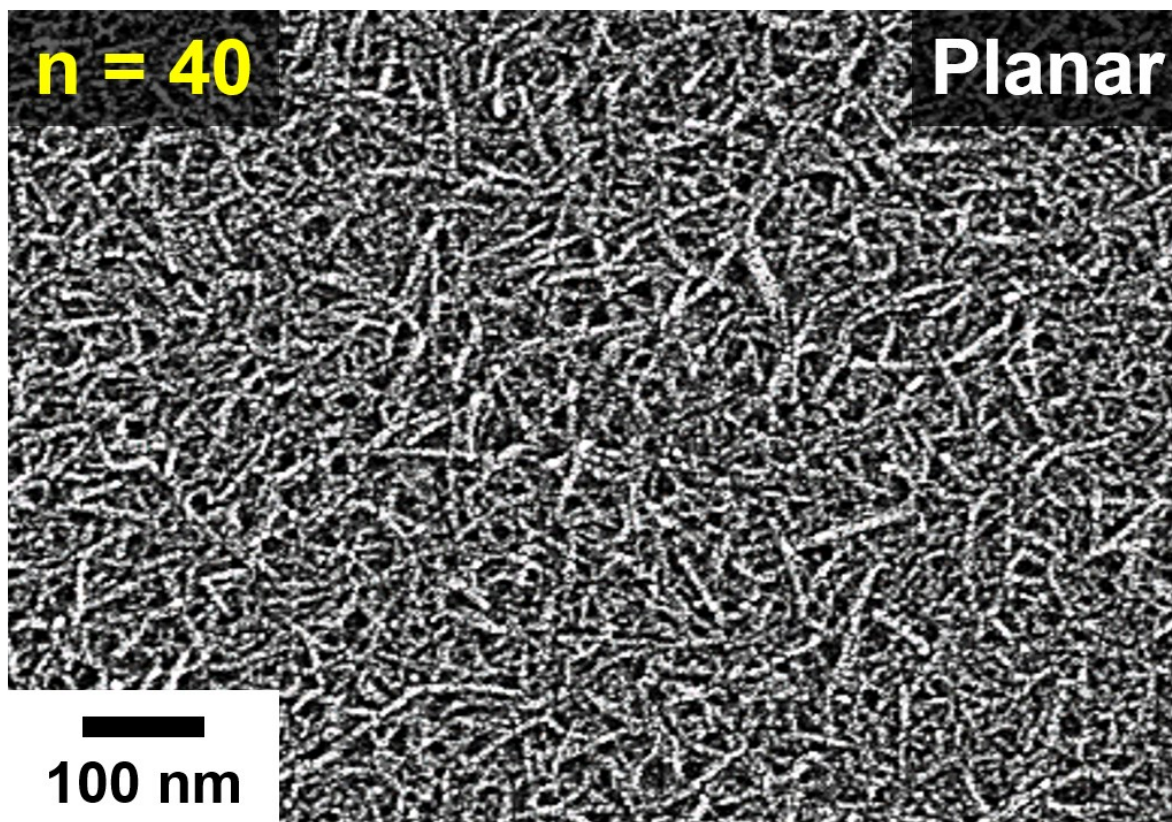


Fig. S3 Enlarged planar FE-SEM image of $(\text{WO}_{2.72} \text{ NR/TREN})_{40}$ multilayers. As shown in the image, the continuous deposition of NR-type $\text{WO}_{2.72}$ forms a porous structure due to the random packing effects, which can facilitate an intercalation of Li^+ ions and an incorporation of additional transparent/conductive ITO NPs.

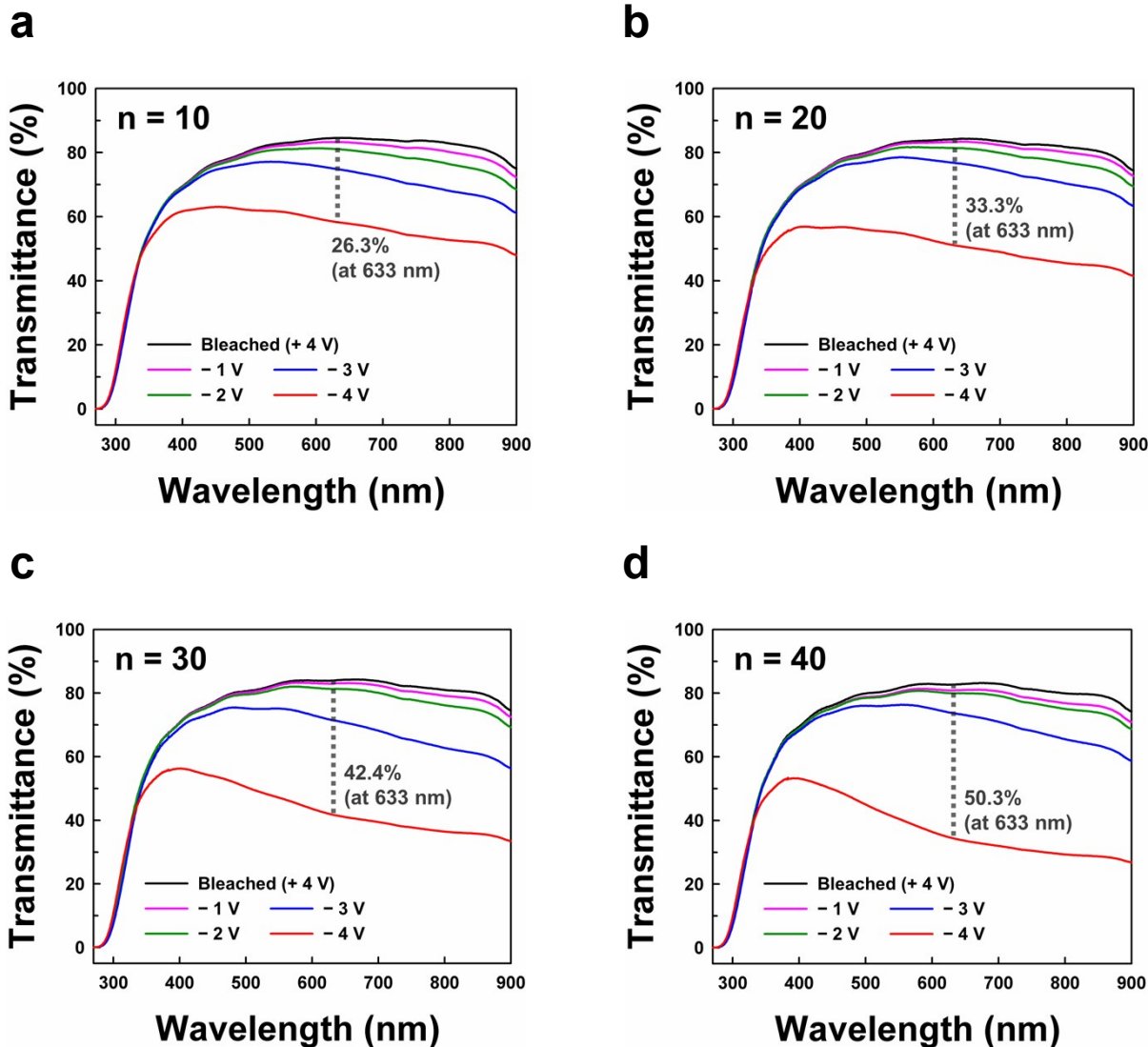


Fig. S4 Optical transmittance spectra of $(\text{WO}_{2.72} \text{ NR/TREN})_n$ multilayers as a function of bilayer number (n) under applied potentials ranging from -1.0 V to -4.0 V . The optical modulations are obtained from the variations of transmittance between bleached state ($+4.0 \text{ V}$) and colored state (-4.0 V) at a wavelength of 633 nm . (a) $n = 10$, (b) $n = 20$, (c) $n = 30$, and (d) $n = 40$.

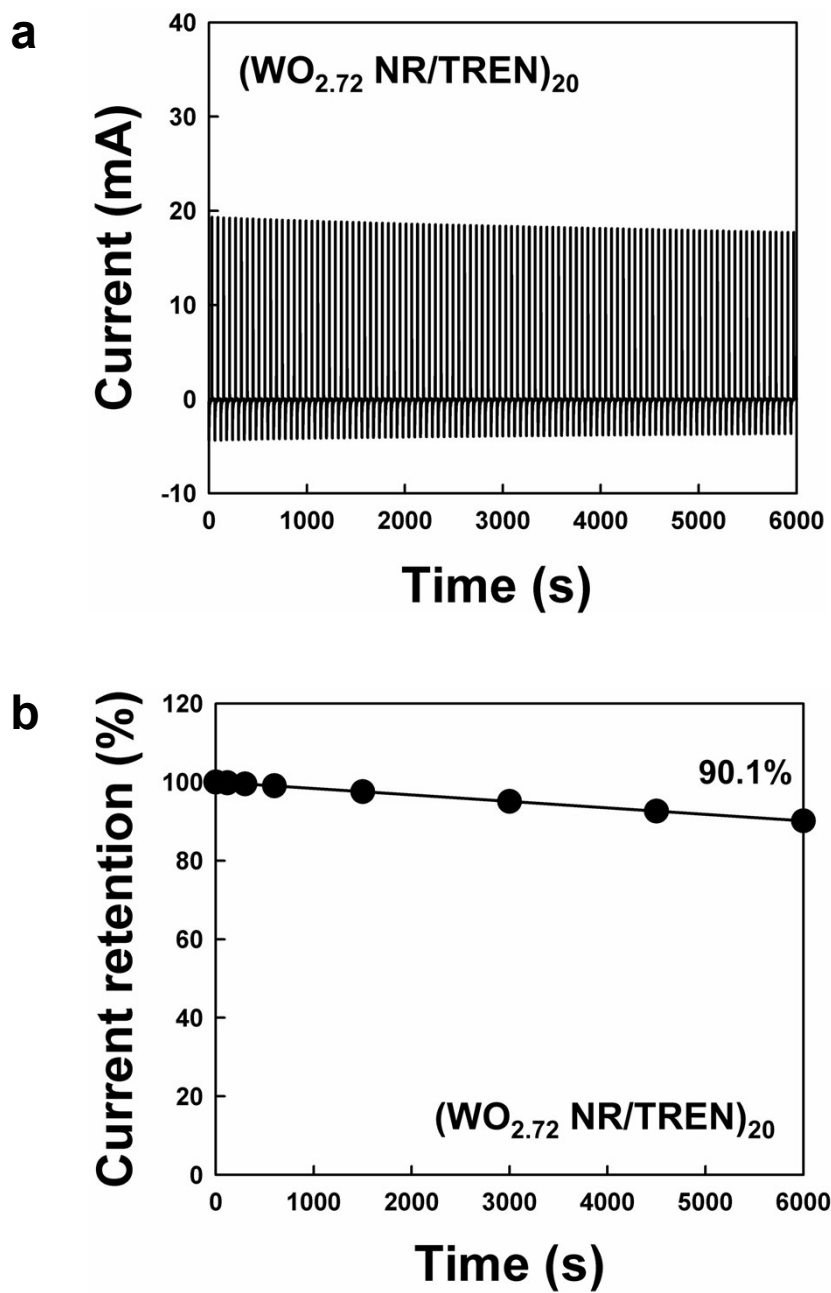


Fig. S5 Stability test of (WO_{2.72} NR/TREN)₂₀ multilayers under alternating potentials of -4.0 V and $+4.0$ V for 30 s interval.

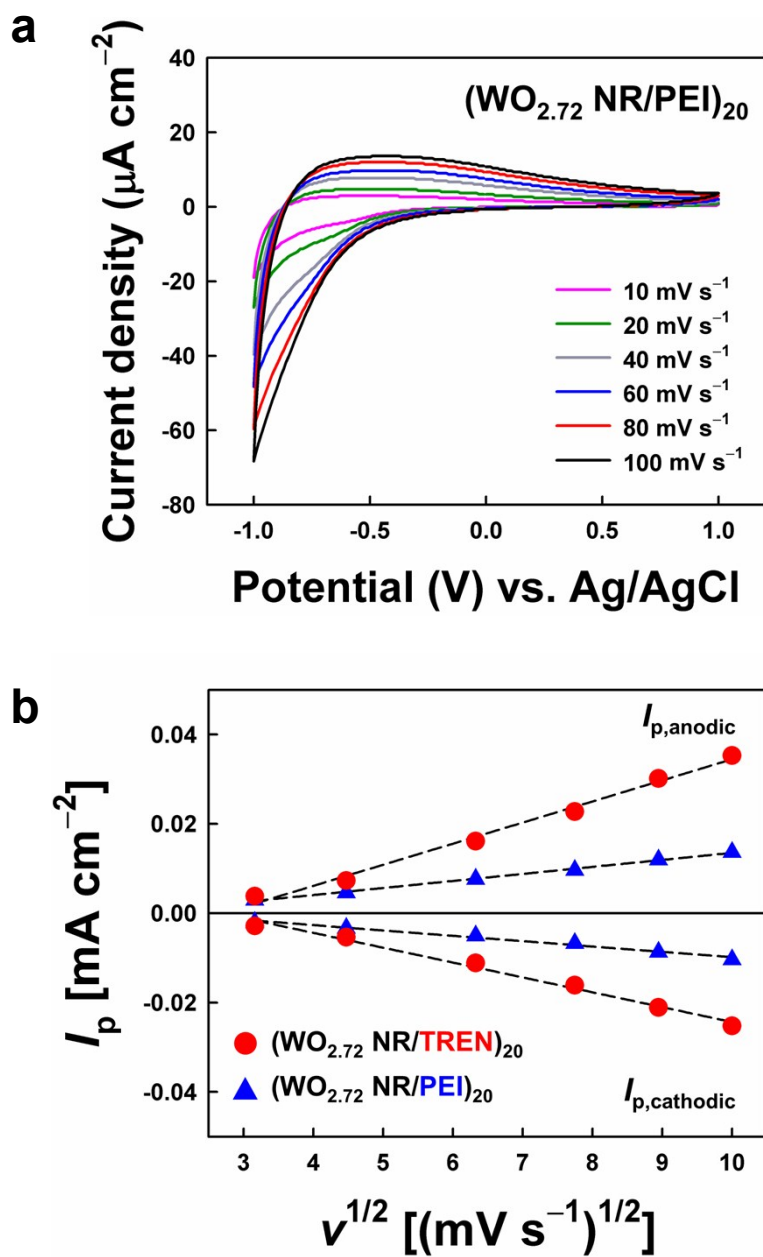


Fig. S6 (a) Cyclic voltammograms of (WO_{2.72} NR/PEI)₂₀ multilayers in a scan rate ranging from 10 to 100 mV s^{-1} . (b) Square root of scan rates ($v^{1/2}$)-dependent redox peak current densities (I_p) from CV curves of (WO_{2.72} NR/TREN)₂₀ and (WO_{2.72} NR/PEI)₂₀ multilayers.

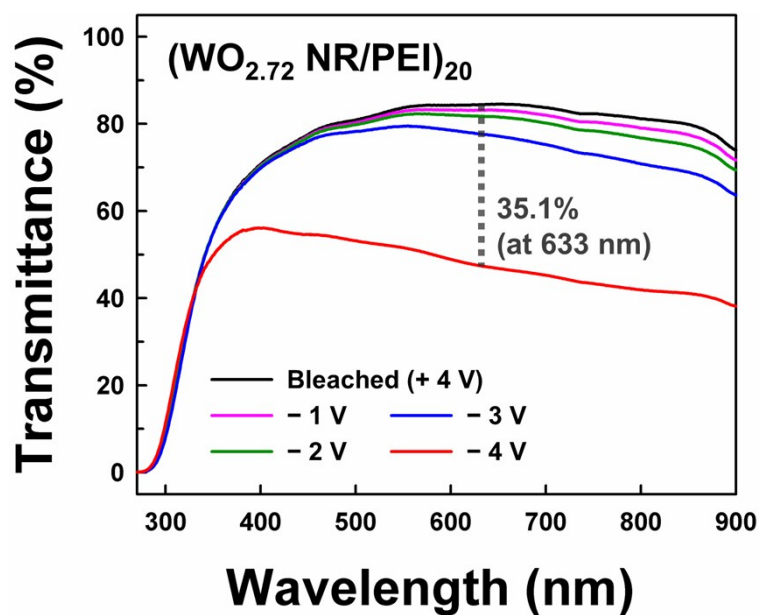


Fig. S7 Optical transmittance spectra of (WO_{2.72} NR/PEI)₂₀ multilayers at colored state (from -1.0 V to -4.0 V). In this case, the optical modulations between bleached state (+4.0 V) and colored state (-4.0 V) at a wavelength of 633 nm is measured to be 35.1%.

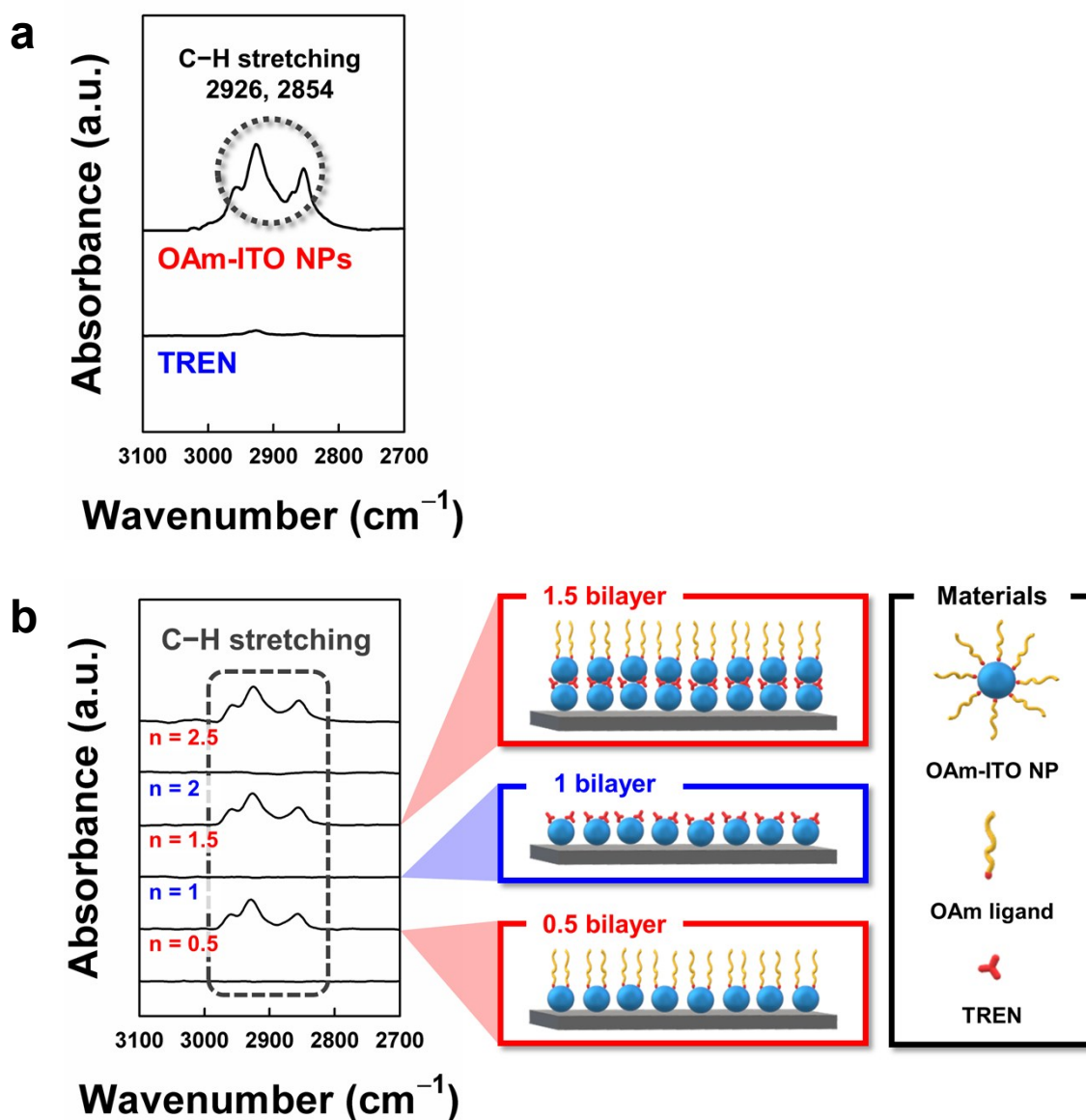


Fig. S8 (a) FTIR spectra of pristine OAm-ITO NPs and TREN. (b) FTIR spectra and schematic representation of $(\text{ITO NP/TREN})_n$ multilayers as a function of bilayer number (n). The C–H stretching peaks originated from the long alkyl chains of OAm ligands at $2,926$ and $2,854\text{ cm}^{-1}$ appeared and disappeared repeatedly according to the alternating deposition of OAm-ITO NPs and TREN. These phenomena imply a formation of $(\text{ITO NP/TREN})_n$ multilayers through ligand-exchange reactions between OAm ligands and TREN.

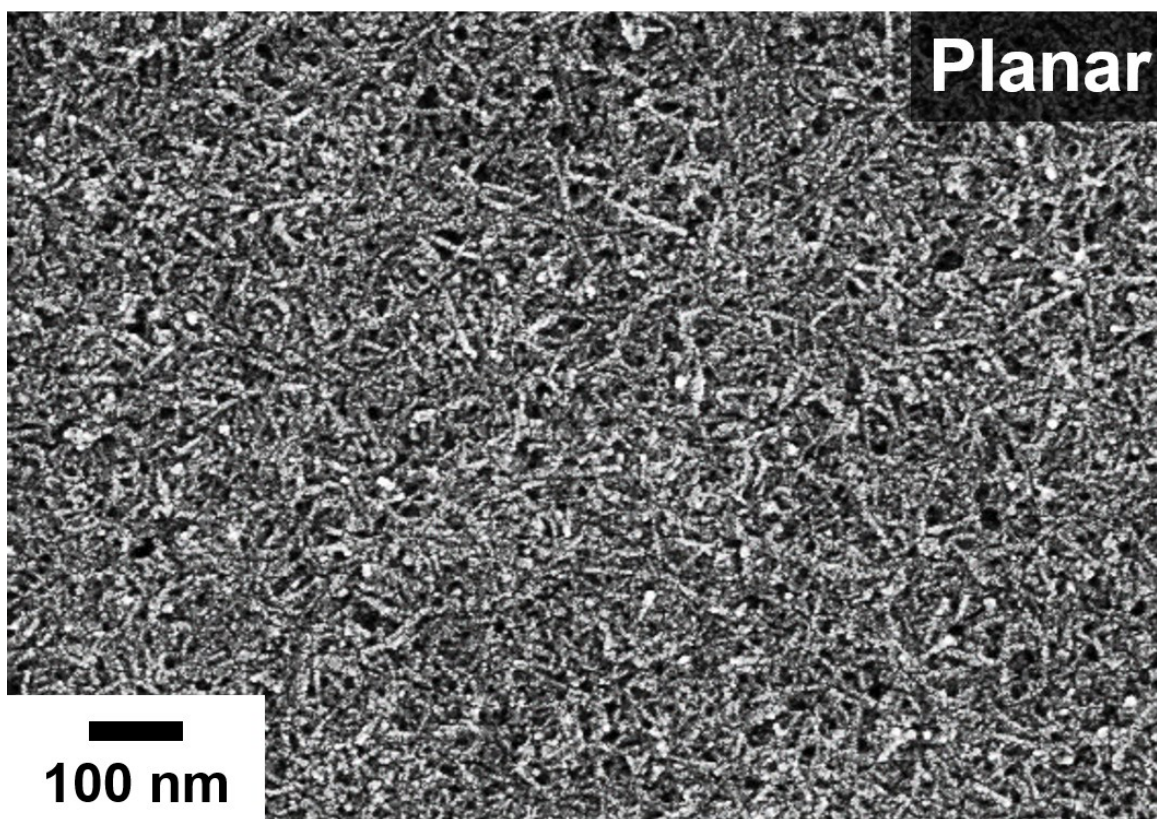


Fig. S9 Magnified planar FE-SEM image of $(\text{WO}_{2.72} \text{ NR/TREN/ITO NP/TREN})_{20}$ multilayers. As shown in the image, the formed multilayers still exhibited nanoporous structure after the incorporation of ITO NPs, facilitating the diffusion of Li^+ ions into the EC films.

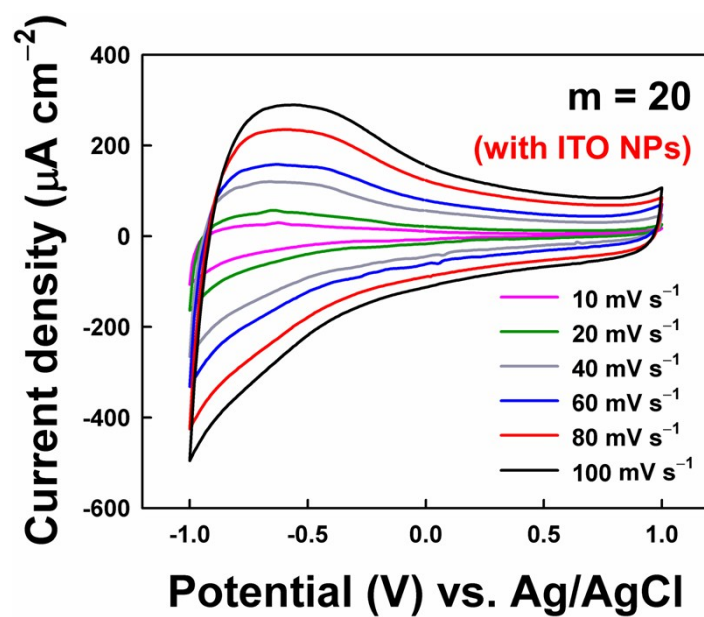


Fig. S10 Cyclic voltammograms of $(\text{WO}_{2.72} \text{ NR/TREN/ITO NP/TREN})_{20}$ multilayers in a scan rate ranging from 10 to 100 mV s^{-1} .

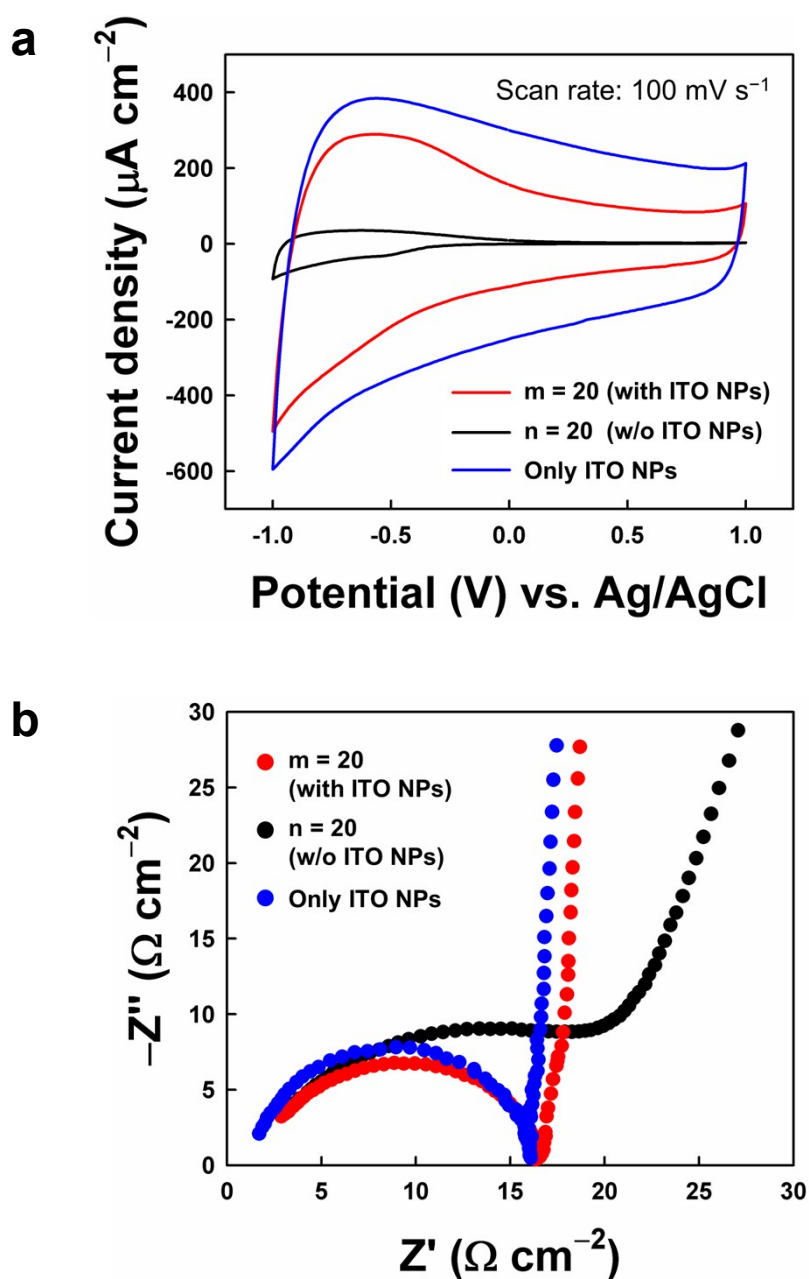


Fig. S11 (a) Cyclic voltammograms at a scan rate of 100 mV s^{-1} and (b) Nyquist plots of $\text{WO}_{2.72}$ NR-based EC films with ITO NPs ($m = 20$), without ITO NPs ($n = 20$), and the pristine ITO NP films.

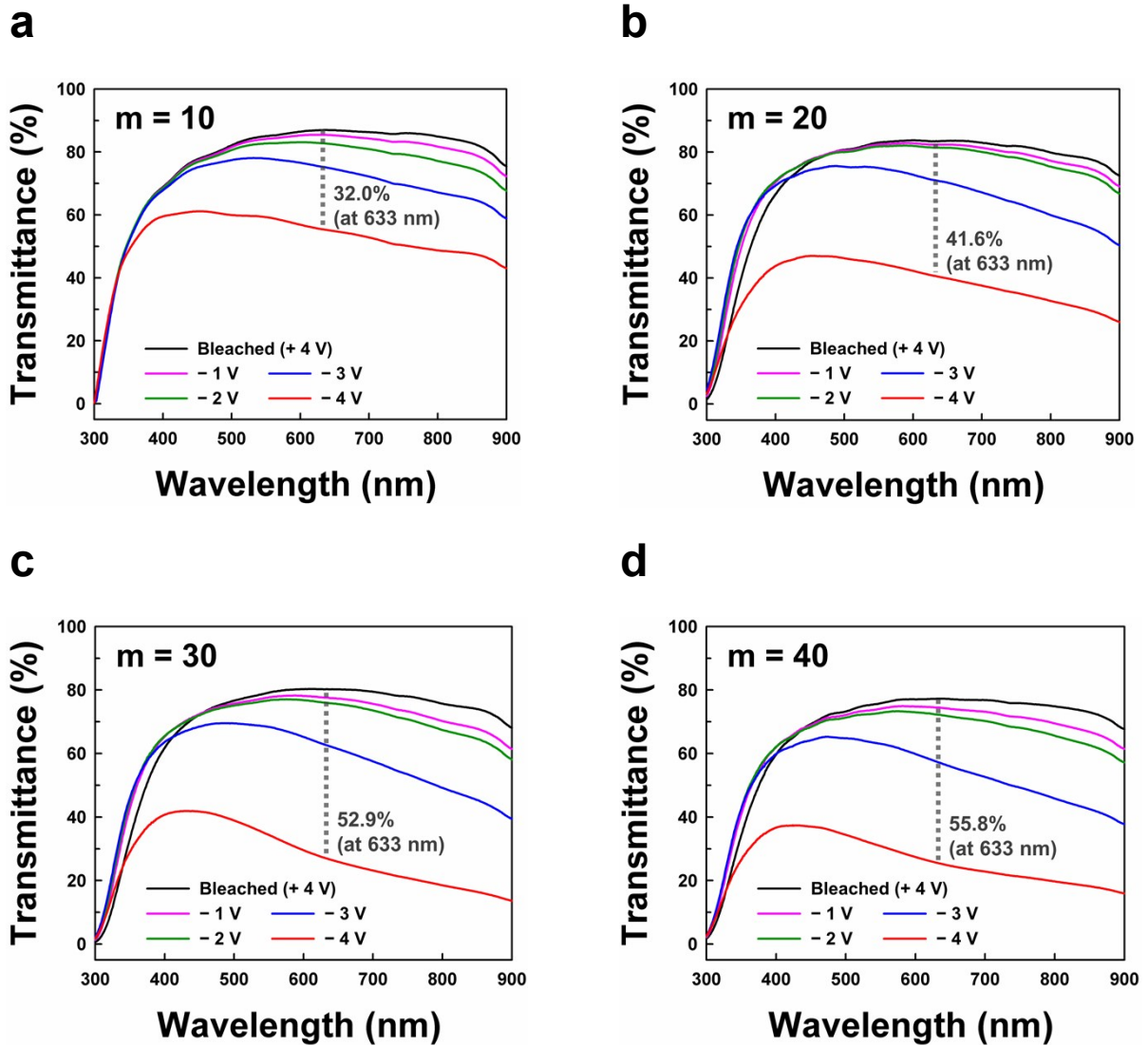


Fig. S12 Optical transmittance spectra of $(\text{WO}_{2.72} \text{NR/TREN/ITO NP/TREN})_m$ multilayers with increasing periodic number (m) under applied potentials ranging from -1.0 V to -4.0 V . The optical modulations between bleached state ($+4.0 \text{ V}$) and colored state (-4.0 V) at a wavelength of 633 nm are also shown. (a) $m = 10$, (b) $m = 20$, (c) $m = 30$, and (d) $m = 40$.

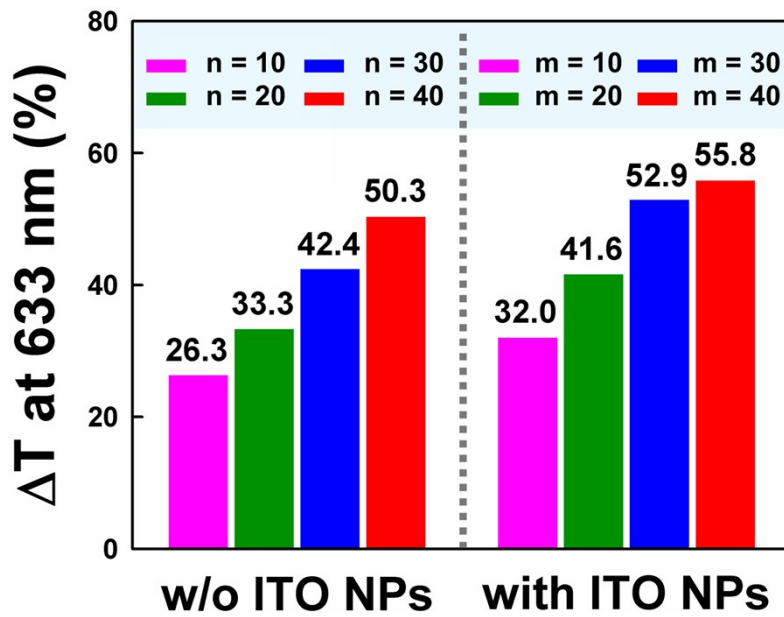


Fig. S13 Comparison of optical modulations at a wavelength of 633 nm between $(\text{WO}_{2.72} \text{ NR/TREN})_n$ and $(\text{WO}_{2.72} \text{ NR/TREN/ITO NP/TREN})_m$ multilayers as a function of bilayer (n) or periodic (m) number. The $\text{WO}_{2.72}$ NR-based EC films with ITO NPs exhibit the higher optical modulations at the same layer number of $\text{WO}_{2.72}$ NRs compared to the EC films without ITO NPs.

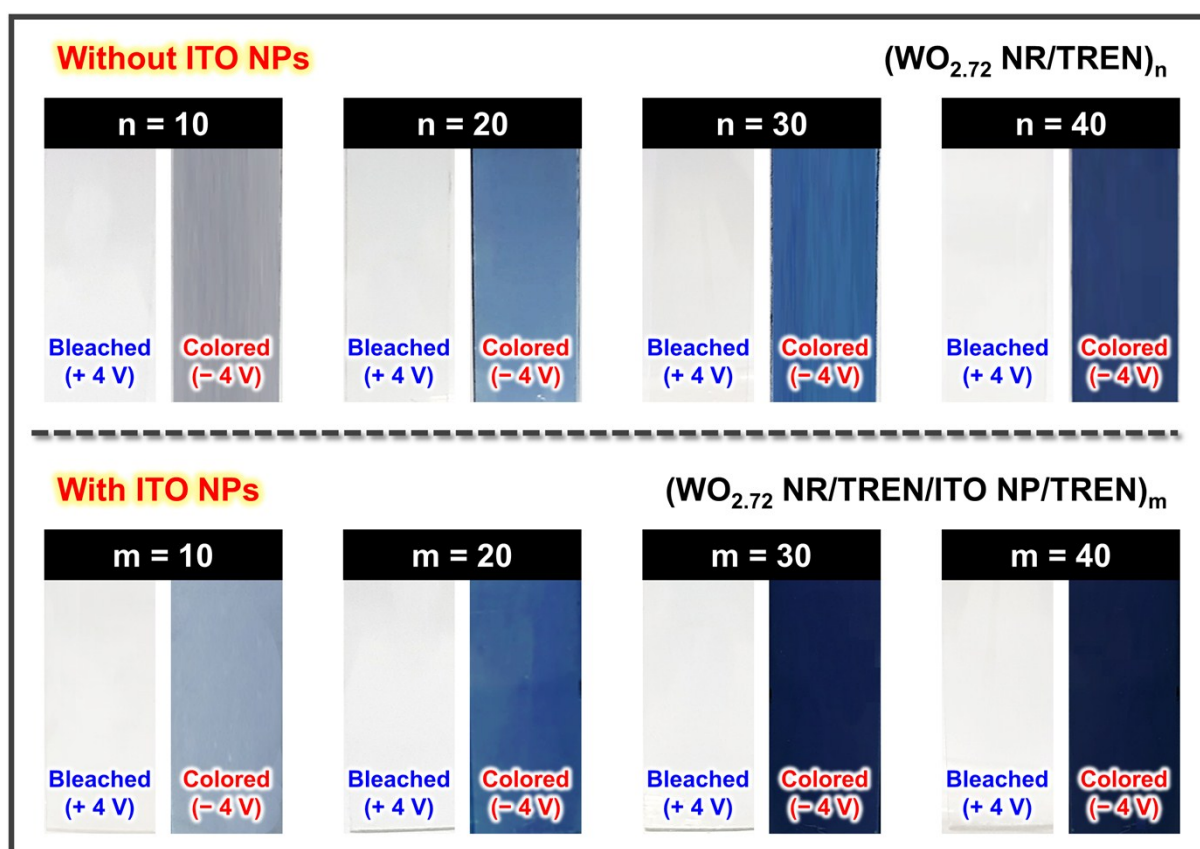


Fig. S14 Photographic images of electrochromic $(\text{WO}_{2.72} \text{ NR/TREN})_n$ and $(\text{WO}_{2.72} \text{ NR/TREN/ITO NP/TREN})_m$ multilayers under applied potentials of + 4.0 V (bleached state) and - 4.0 V (colored state). In this case, the $\text{WO}_{2.72}$ NR-based EC films with ITO NPs display a deeper color change than the EC films without ITO NPs.

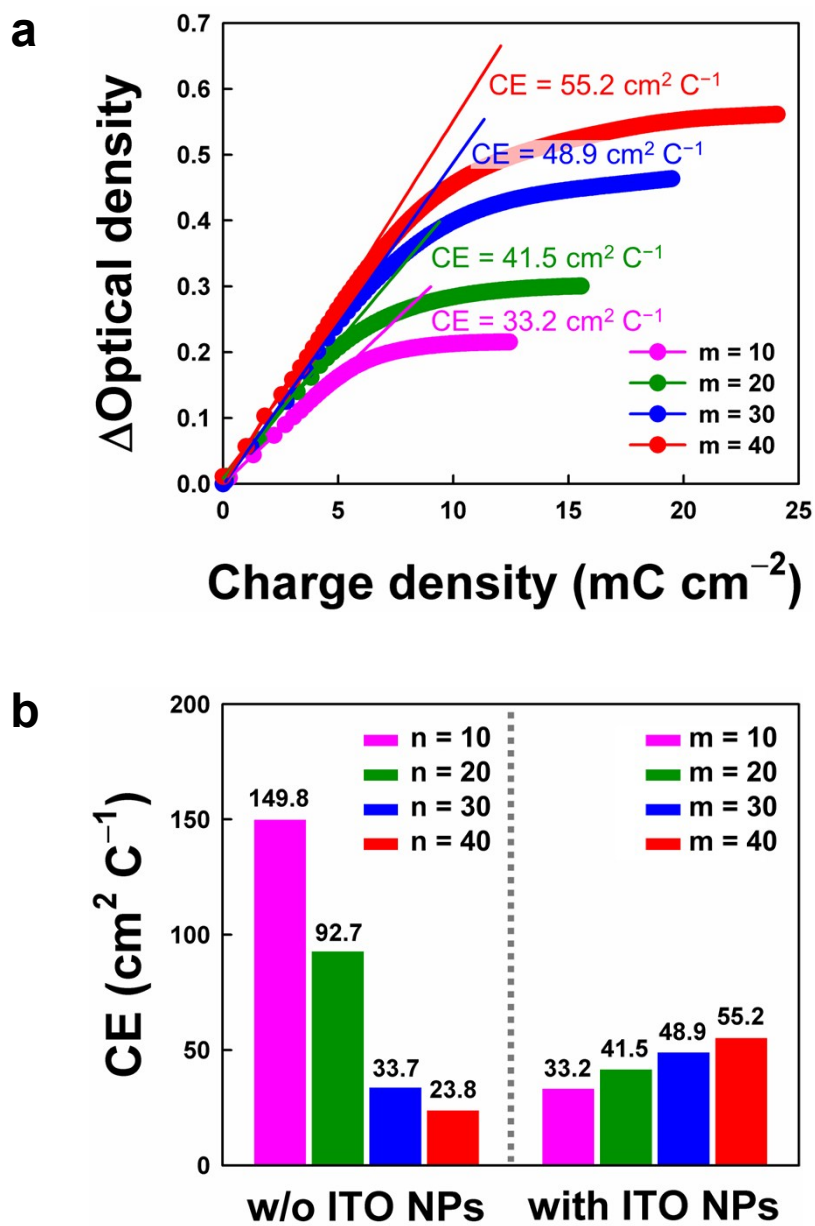


Fig. S15 (a) CEs of $(\text{WO}_{2.72} \text{ NR/TREN/ITO NP/TREN})_m$ multilayers as a function of periodic number (m). (b) Comparison of CEs between $(\text{WO}_{2.72} \text{ NR/TREN})_n$ and $(\text{WO}_{2.72} \text{ NR/TREN/ITO NP/TREN})_m$ multilayers at the same layer number of $\text{WO}_{2.72}$ NRs.

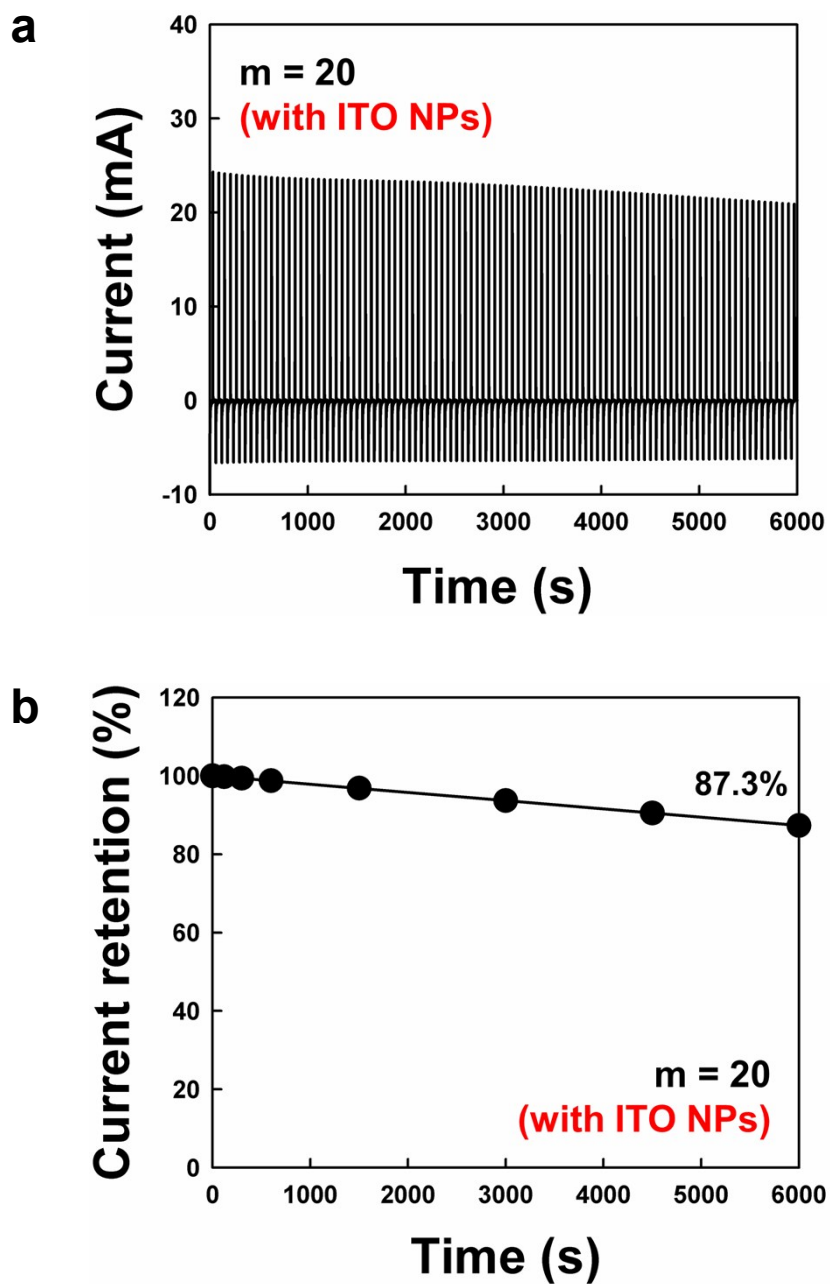


Fig. S16 Cycling retention test of $(\text{WO}_{2.72} \text{ NR/TREN/ITO NP/TREN})_{20}$ multilayers under alternating potentials of -4.0 V and $+4.0 \text{ V}$ for 30 s interval.

Table S1. Comparison of EC performance of WO_x-based films in lithium-based electrolytes.

Electrodes	Method	t _c (s)	t _b (s)	ΔT (%)	CE (cm ² /C)	Reference
(WO _{2.72} NR/TREN /ITO NP/TREN) ₁₀	LbL assembly	4.1	1.5	32.0 at 633 nm	33.2	Our work
(WO _{2.72} NR/TREN /ITO NP/TREN) ₂₀	LbL assembly	5.0	3.0	41.6 at 633 nm	41.5	Our work
(WO _{2.72} NR/TREN /ITO NP/TREN) ₃₀	LbL assembly	8.2	11.4	52.9 at 633 nm	48.9	Our work
(WO _{2.72} NR/TREN /ITO NP/TREN) ₄₀	LbL assembly	10.9	15.2	55.8 at 633 nm	55.2	Our work
WO _{2.72} NW films	Langmuir-Blodgett	10	2	11.5 at 633 nm**	-	S1
WO _{2.72} NW films	Langmuir-Blodgett	30	16	49.2 at 633 nm**	-	S1
MoO ₃ -W _{0.71} Mo _{0.29} O ₃ hybrid films*	Drop casting	17.2	28.4	41.9 at 633 nm	19.0	S2
WO ₃ /Ag/WO ₃ films	Sputtering deposition	15.9	6.6	35.5 at 650 nm	28.3	S3
P ₈ W ₄₈ /W ₁₈ O ₄₉ nanocomposites*	LbL assembly	52	26	39.0 at 500 nm**	21.4	S4

$W_{0.71}Mo_{0.29}O_3$ /PEDOT:PSS nanocomposites	Spray LbL assembly	17.9	10.5	65.1 at 633 nm	52.8	S5
Hyperbranched WO_3 films	Pulsed laser deposition	0.9	55	67.3 at 660 nm	65.4	S6
Dual-phase α - WO_3 / WO_3 films	Inkjet printing	5	5	12.8 at 633 nm**	3.12	S7
WO_3 films	Langmuir-Blodgett	>3.6	>3.1	25.9 at 630 nm	71.3	S8
$[WO_2(O_2)H_2O] \cdot 1.66H_2O$ films	Electrophoretic deposition	7.8	1.7	32.0 at 632 nm	11.5	S9
PEI/ WO_3 nanosheets nanocomposites	LbL assembly	660	11	37.5 at 633 nm**	32.0	S10

* Mo: Molybdenum, P_8W_{48} : $K_{28}Li_5H_7P_8W_{48}O_{184} \cdot 92H_2O$ polyoxometalates.

** EC performance was evaluated from given data in the literature.

Supplementary references

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